



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 15, 2025

IGI Report Number **LG749529849**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.27 X 7.15 X 4.46 MM**

GRADING RESULTS

Carat Weight **2.05 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

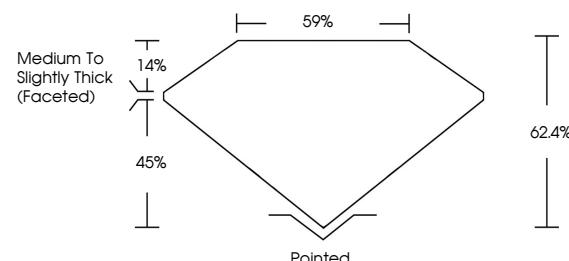
Fluorescence **NONE**

Inscription(s) **IGI LG749529849**

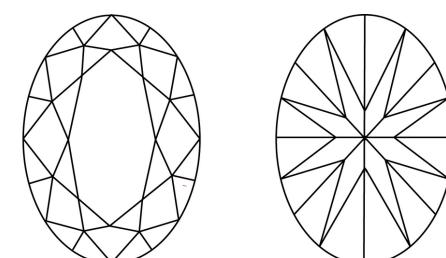
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG749529849
Report verification at igi.org

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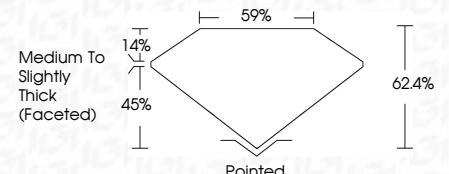
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Sample Image Used



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IGI



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November 15, 2025	IGI Report No LG749529849
OVAL BRILLIANT	
Carat Weight	2.05 CARATS
Color Grade	F
Clarity Grade	VVS 2
Depth	62.4%
Table Grade	59%
Girdle	Medium To Slightly Thick (Faceted)
Polish	Pointed
Symmetry	EXCELLENT
Fluorescence	EXCELLENT
Inscription(s)	NONE
Comments:	This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
	Type IIa